

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/595,660 Confirmation No. 4264
Applicant : Yuichiro Shindo
371 Filed : May 3, 2006
Art Unit : 1733
Examiner : Jessee Randall Roe
Customer No. : 00270
Title : HIGH PURITY HAFNIUM, TARGET AND THIN FILM
COMPRISING SAID HIGH PURITY HAFNIUM, AND
METHOD FOR PRODUCING HIGH PURITY HAFNIUM

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE

Sir:

This is a Response timely submitted to a non-final Office Action dated July 27, 2011.

Remarks/Arguments begin on page 2 of this paper.